



AMAT CENTURA II DPS Poly Etch System

Manufacturer:	Applied Materials
Model:	Centura II
Vintage:	Fully refurbished
Wafer Size:	200mm (8")
Serial Number:	318529
Process:	DPS Poly etch
Configuration:	Widebody loadlocks HP robot OTF Seriplex gas panel Position A: DPS R1 poly Position B: DPS R1 poly Position C: DPS R1 poly Position E: Orientor DPS R1 Poly Chamber Detail - DPS R1 poly (upper, lower, HR DTCU) - Polymide ESC - Leybold 2000 turbo - Endpoint dectector - Heated foreline/gate valve - Throttling gate valve - RFPP RF20S generator - RFPP RF5S generator

